

Electronic Acknowledgement Receipt

EFS ID:	1467345
Application Number:	10706862
International Application Number:	
Confirmation Number:	6724
Title of Invention:	COMPOSITION FOR FORMING POROUS FILM, POROUS FILM AND METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR FILM, AND SEMICONDUCTOR DEVICE
First Named Inventor/Applicant Name:	Tsutomu Ogihara
Customer Number:	826
Filer:	Andrew T. Meunier/elaine kelly
Filer Authorized By:	Andrew T. Meunier
Attorney Docket Number:	035576/271443
Receipt Date:	26-JAN-2007
Filing Date:	12-NOV-2003
Time Stamp:	10:10:40
Application Type:	Utility

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Certificate of Correction	271443CertofCorrection.pdf	152583	no	2

Warnings:

Information:**Total Files Size (in bytes):**

152583

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.